



IFW

PATENT
Customer No. 22,852
Attorney Docket No. 04329.3172

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
Keiji Fujita, et al.)	Group Art Unit: 2813
)	
Application No.: 10/701,476)	Examiner: Thanh Ha Pham
)	
Filed: November 6, 2003)	
)	
For: SEMICONDUCTOR DEVICE)	Confirmation No.: 8591
FABRICATION METHOD (As)	
amended))	

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT

In reply to the Office Action mailed January 11, 2005, the period for response extending through April 11, 2005, please amend the above-identified application as follows:

Amendments to the Specification are included in this paper.

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks/Arguments follow the amendment sections of this paper.